

## Long-Range Proximity Effect in Aluminum Thin Films with Spatially Modulated $T_c$

Y. K. Kwong, K. Lin, M. S. Isaacson, and J. M. Parpia

*School of Applied and Engineering Physics and the Laboratory of Atomic and Solid State Physics,  
Cornell University, Ithaca, New York 14853*

(Received 16 July 1990)

We report resistive measurements on a thin-film analog of a modulated-transition-temperature superlattice. The aluminum film was reactive-ion etched in strips perpendicular to the current path, decreasing  $T_c$  of the etched sections by  $\approx 2\%$ , thus spatially modulating the transition temperature. At current densities  $\leq 600$  A/cm<sup>2</sup>, the resulting structures exhibit a single homogeneous transition for etched lengths up to 50  $\mu\text{m}$ , substantially longer than expected from the order-parameter decay length of 0.81  $\mu\text{m}$  for the proximity effect in the dirty limit.

PACS numbers: 74.75.+t, 74.50.+r

Superconducting junctions<sup>1,2</sup> and superlattices<sup>3</sup> have been extensively studied before. For a superconductor-normal-metal-superconductor ( $S$ - $N$ - $S$ ) junction, the order parameter in the normal region decays exponentially over a characteristic length  $K_N^{-1}$ . Providing that the critical current is not exceeded, the junction should display a sharp resistive transition. For larger currents, or longer lengths of the normal material, this homogeneity disappears, giving rise to discrete resistive transitions.

In this Letter, we report results on a thin-film analog of a modulated- $T_c$  superlattice. This system exhibits strong proximity effects over a length scale quantitatively incompatible with the standard picture outlined above (originally formulated by de Gennes<sup>4</sup> and Werthamer<sup>5</sup>). Our samples consistently exhibit sharp resistive transitions for normal<sup>6</sup> regions up to 50  $\mu\text{m}$  and for current densities up to 600 A/cm<sup>2</sup>. This length is substantially longer than  $K_N^{-1}$  for thin-film aluminum in the dirty limit. Thus, superconductivity in this system persists over an unexpectedly long length scale.

Our samples are patterned aluminum thin films (thickness 250  $\text{\AA}$ , width 200  $\mu\text{m}$ , and length 2 mm), simultaneously vapor deposited onto a silicon-nitride/silicon substrate. To modulate the  $T_c$ , a sample is coated with photoresist material and openings defined by photolithography. A reactive-ion etching process (described elsewhere<sup>7</sup>) is then performed, in which the undeveloped photoresist acts as an etch mask.<sup>8</sup> This process changes the  $T_c$  of the etched regions by  $\approx 2\%$  with respect to the  $T_c$  of the unetched region. The mechanism for the change of  $T_c$  in the etched films is not understood. In our previous study,<sup>7</sup> the  $T_c$  of the etched region was enhanced by  $\sim 40$  mK relative to the unetched sample. The etch used in the present study had a higher energy density than in the previous study and the sample stage was cooled during processing, resulting in a suppression of  $T_c$  by  $\sim 30$  mK. We speculate that surface and substrate conditions are likely to be affected by these changes in the processing conditions and may be the controlling factors in the absolute  $T_c$  shifts.

A sample typically has fourteen modulated films,

fabricated simultaneously on the same substrate under identical conditions. Each modulated film has different etched and unetched lengths,  $d_1$  and  $d_2$ , respectively, patterned in series with one another. (One film is shown schematically in Fig. 1.) For control, uniformly etched and unetched films are always available on each sample. The  $T_c$ 's of these uniform regions are referred to as  $T_{c1}$  and  $T_{c2}$ , respectively. A notable difference between this work and previous studies of others is that the constituents of our "superlattice" have nearly identical  $T_c$ 's.

Our etching process is fairly noninvasive. The residual-resistance ratios (RRR) of the etched and unetched regions differ by no more than 0.5% and the sheet resistance by no more than 10%. The diffusion constants, as determined by the slope of the upper critical field as a function of temperature,<sup>9</sup> differ by no more than 20%. The similar resistive transition widths are further evidence of the consistent quality of the etched and unetched films.

The nature (whether discrete or homogeneous) of the resistive transitions was investigated by varying  $d_1$  and  $d_2$ . Since the patterns were defined lithographically, these dimensions can be conveniently controlled with great accuracy. We have elected to fabricate the films in two configurations: (i)  $d_1/d_2$  was held fixed while the modulation period,  $d_1+d_2$  (denoted as  $\Lambda$ ), was varied; (ii)  $d_1$ , or  $d_2$ , was held fixed while the ratio  $d_1/d_2$  was

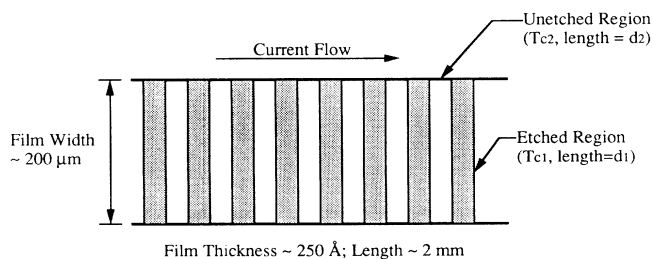


FIG. 1. Schematic of a modulated  $T_c$  structure, illustrating etched and unetched regions ( $d_1$ , etched length;  $d_2$ , unetched length).

varied. As  $T_c$ 's tend to vary from sample to sample, we have found it convenient to study samples containing both configurations, thus allowing a systematic examination of the  $T_c$  of the modulated structures for particular values of  $T_{c1}$  and  $T_{c2}$ .

Unless otherwise specified, all measurements were carried out at a current density of 6 A/cm<sup>2</sup>, using a standard four-terminal ac resistance bridge operating at 17 Hz. The resistance was measured by applying a constant current through a common pair of leads, while pairs of voltage leads corresponding to particular modulation periods  $\Lambda$  were monitored. In this Letter,  $T_c$  was chosen as the temperature where the normalized resistance equals one-half.<sup>10</sup> The uncertainty in  $T_c$  is taken to be  $\pm 0.5$  mK, the resolution of our thermometry and temperature control. Our quoted values of  $d_1$  and  $d_2$  have a systematic uncertainty of  $\pm 0.2$   $\mu\text{m}$ , the typical line-width control achieved in our lithographic process. Because of the excellent etch resistance of the photoresist, the resulting interface "roughness" is less than this value.

The striking nature of the resistive transitions is clearly seen in samples with a unity ratio of  $d_1/d_2$ , while  $\Lambda$  was varied from 4 to 400  $\mu\text{m}$ . The resulting transitions are shown in Figs. 2(a) and 2(b) (data sets<sup>11</sup> *F* and *D*) in which the normalized resistance of the various films is plotted against the temperature. In Fig. 2(a), we plot the transitions of four films with  $\Lambda = 4, 10, 20,$  and 100  $\mu\text{m}$ , along with the normalized resistance of a uniformly etched film on the left and a uniformly unetched film on the right. This sample exhibits sharp resistive transitions for these modulation periods, demonstrating that the proximity effect extends over a length scale of at least 50  $\mu\text{m}$  (length of the etched section). This length scale is in quantitative disagreement with the de Gennes-

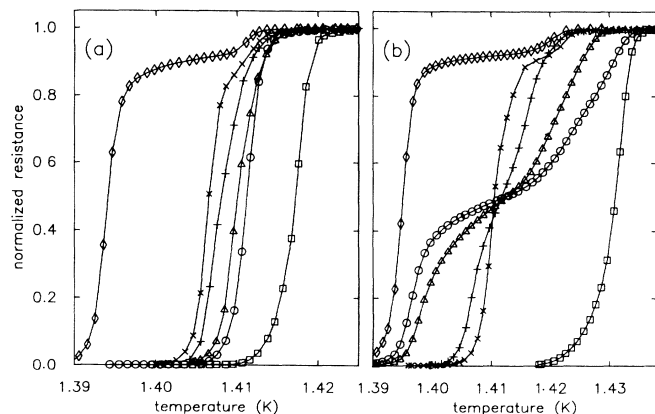


FIG. 2. Resistive transitions for data sets (a) *F* and (b) *D* with unity ratio  $d_1/d_2$ . In both (a) and (b),  $\diamond$  and  $\square$  are the uniformly etched and unetched films. In (a), resistive transitions shown are  $\times$ ,  $+$ ,  $\triangle$ , and  $\circ$  for  $\Lambda = 4, 10, 20,$  and 100  $\mu\text{m}$ . In (b), resistive transitions shown are  $\times$ ,  $+$ ,  $\triangle$ , and  $\circ$  corresponding to  $\Lambda = 20, 100, 200,$  and 400  $\mu\text{m}$ .

Werthamer theory. We will elaborate on this point later in this Letter. As  $\Lambda$  is increased, the single transition should break up into two discrete transitions. This trend is borne out in our experiment and is illustrated in Fig. 2(b) for another sample with  $\Lambda \geq 100$   $\mu\text{m}$ . A pronounced shoulder develops at the half resistance point, consistent with the geometry. We note that the system does not yet display two discrete transitions for  $\Lambda$  as large as 400  $\mu\text{m}$ .

There are other noteworthy features in the data shown in Fig. 2. The shoulder observed at a normalized resistance of  $\approx 0.9$  is likely an artifact of sample geometry, or possibly associated with *S-N* interfaces between voltage probes and the films under study. It should be emphasized that this feature is present even in the uniformly etched film and is unrelated to the onset of the resistive transition in the modulated structures. Figure 2(a) also shows that an increase in  $\Lambda$  produces an increase in  $T_c$  of the modulated structure. This unexpected characteristic was observed in all samples measured in this study. Last, the resistive transitions are sensitive to the  $T_c$  difference  $\Delta T_c \equiv T_{c2} - T_{c1}$ . This has the consequence that the onset of discrete transitions is shifted to larger  $\Lambda$  for samples with smaller  $\Delta T_c$ .

To unambiguously demonstrate that these observations are not the result of processing artifacts (which would presumably extend over a fixed length), we have examined structures in which the unetched length ( $d_2$ ) was held fixed at 2 or 5  $\mu\text{m}$ , while the etched lengths were varied so as to span a ratio of  $d_1/d_2$  from 0.5 to 10. All transitions were sharp, consistent with the picture of a single homogeneous transition. The results for data set *E1* with  $d_2 = 5$   $\mu\text{m}$  are shown in Fig. 3. Similar experiments were carried out on samples with a fixed  $d_1$  of 5  $\mu\text{m}$  while the ratio  $d_1/d_2$  was varied over the same range of values. Again, the normalized  $T_c$  decreased smoothly and monotonically with increasing  $d_1/d_2$ , and, in fact,

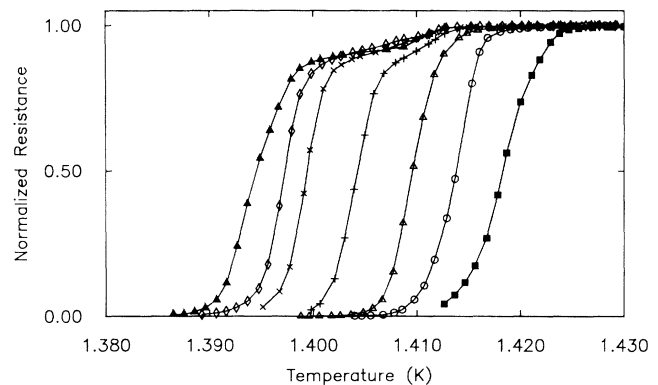


FIG. 3. Resistive transitions for data set *E1* in which the ratio of etched to unetched lengths ( $d_1/d_2$ ) is varied from 0.5 to 10 while  $d_2$  is fixed and 5  $\mu\text{m}$ .  $\blacksquare$  and  $\blacktriangle$  are the uniformly unetched and uniformly etched films. The symbols  $\circ$ ,  $\triangle$ ,  $+$ ,  $\times$ , and  $\diamond$ , correspond to etched lengths of 2.5, 5, 10, 25, and 50  $\mu\text{m}$ , respectively.

the data of Fig. 3 were reproduced. This evidence confirms the absence of etching-induced artifacts on the masked regions.

Previous experiments have propagated supercurrents across dirty  $S$ - $N$ - $S$  junctions of many coherence lengths.<sup>12,13</sup> To assess the strength of the proximity effect in our system, we have measured the effects of higher excitation currents and weak applied magnetic fields. In Fig. 4, we plot the resistive transitions for the etched, unetched, and the  $\Lambda = 100 \mu\text{m}$  films of Fig. 2(a). The suppression of the transition temperatures at current densities up to  $600 \text{ A/cm}^2$  are shown for the etched and  $\Lambda = 100 \mu\text{m}$  films. The sharp and uniform nature of the transitions is maintained at these current densities, supporting our identification of a strong, long-range proximity effect. (Higher current densities could not be explored using these samples due to heating effects.) For homogeneous thin films close to  $T_c$ , the current density varies as<sup>9</sup>  $J_c = J_{c0}(1 - T/T_c)^{3/2}$ . For the uniformly etched film, we estimate (using the data of Fig. 3) the constant  $J_{c0}$  to be  $\approx 2.3 \times 10^6 \text{ A/cm}^2$ . This is a reasonable value for thin films.

A magnetic field of 1 mT produced noticeably broader transitions and suppressed  $T_c$  by  $\approx 50 \text{ mK}$ . However, the homogeneous signature of the resistive transition was preserved in these fields. Typical thin-film behavior was observed down to  $\approx 0.4 \text{ K}$ , in fields up to 30 mT, but substantial broadening of the transitions is present.

To examine the dependence of the transition temperature on the ratio  $d_1/d_2$ , we present the results of three representative data sets ( $D1$ ,  $E$ , and  $E1$ ) in Fig. 5. To facilitate the comparison between data sets, we have nor-

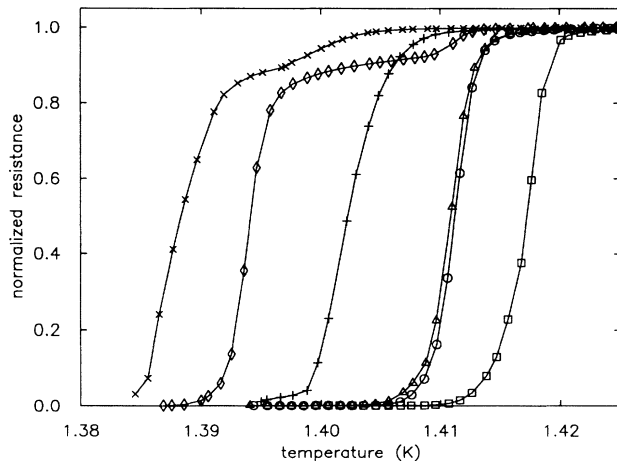


FIG. 4. Resistive transitions of uniformly etched ( $\diamond$ ), unetched ( $\square$ ), and  $\Lambda = 100 \mu\text{m}$  ( $\circ$ ) films at a current density of  $6 \text{ A/cm}^2$ . Also shown are results at  $60 \text{ A/cm}^2$  for the  $\Lambda = 100 \mu\text{m}$  ( $\triangle$ ) film; and at  $600 \text{ A/cm}^2$  for the etched ( $\times$ ) and  $\Lambda = 100 \mu\text{m}$  ( $+$ ) films. Note the homogeneous transitions for all current densities used, confirming the existence of a long length scale.

malized the transition-temperature shift,  $T_c - T_{c1}$ , to  $\Delta T_c$ . The data sets fall on similar curves and can be fitted by the expression

$$\frac{\Delta T_c}{T_c - T_{c1}} = 1 + p \frac{d_1}{d_2}. \quad (1)$$

This is Eq. 6-66 in Ref. 3 (the result of a linearized Ginzburg-Landau treatment of a superlattice), in the limit that the effective coherence length is much longer than the modulation lengths. The factor  $p$ , which is of order unity, is a parameter in the theory related to the logarithmic derivative of the order parameter across an interface. Here, we treat  $p$  as a fitting parameter. We have selected this equation since we observed that the quantity  $T_c - T_{c1}$  was strongly affected by the ratio  $d_1/d_2$  and only weakly dependent on their absolute magnitudes. The  $\Delta T_c$  of our samples was typically between 22 and 46 mK. The fitting parameter  $p$  was found to be of order 1. We note the apparent size dependence of  $p$  (data sets  $E$  and  $E1$  of Fig. 5). These data were taken from films fabricated simultaneously on a single substrate and should have identical values of  $\Delta T_c$ . The two data sets have the same range of the ratios  $d_1/d_2$  but of different fixed unetched lengths ( $d_2 = 2 \mu\text{m}$  for  $E$  and  $d_2 = 5 \mu\text{m}$  for  $E1$ ). The values of  $p$  which best fit the data are 0.9 and 0.75, respectively.

The results presented in this Letter are summarized as follows: (a) The proximity effect extends over lengths up to  $50 \mu\text{m}$ , corresponding to a periodicity of  $100 \mu\text{m}$ . (b) The normalized transition temperatures for  $\Lambda \leq 50 \mu\text{m}$  are determined by the ratio  $d_1/d_2$ . (c) As  $\Delta T_c$  decreases, the normalized transition temperature at which a structure having a fixed value of  $d_1/d_2$  undergoes its superconducting transition increases. (d) There is a weak dependence of the normalized transition temperature on  $\Lambda$ . (Smaller  $\Lambda$  results in a lower  $T_c$  for a fixed ratio of

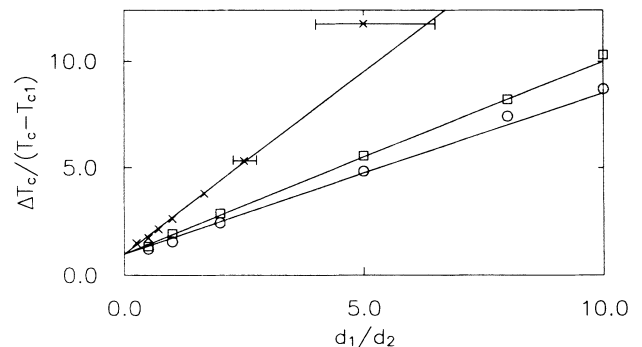


FIG. 5. Reduced data for data sets  $E1$  ( $\circ$ ),  $E$  ( $\square$ ), and  $D1$  ( $\times$ ), with  $\Delta T_c = 23.8, 23.8,$  and  $36.0 \text{ mK}$ , respectively. The inverse normalized  $T_c$  shift is plotted against the ratio  $d_1/d_2$ . Solid lines are fits by Eq. (1) in text for values of the parameter  $p = 0.75, 0.9,$  and  $1.7$ , respectively. Note the dependence of  $p$  on modulation length in the data sets  $E$  and  $E1$ .

$d_1/d_2$ .)

Within the theory of de Gennes and Werthamer, which is applicable<sup>14</sup> to systems in the dirty limit ( $l \ll \hbar v_F/2\pi k_B T$ ), the order parameter decays exponentially in the normal region with a characteristic length<sup>15</sup>

$$K_N^{-1} = \xi_N(T) \left( 1 + \frac{2}{\ln(T/T_{cN})} \right)^{1/2}, \quad (2)$$

where  $\xi_N(T) \equiv (\hbar D/2\pi k_B T)^{1/2}$ ,  $T_{cN} \equiv T_{c1}$ , and  $D$  is the diffusion constant of the normal region. The mean free path  $l$  is estimated to be 120 Å using  $v_F = 1.3 \times 10^8$  cm/s and the experimental value of the diffusion constant  $D = 50 \pm 5$  cm<sup>2</sup>/s. For the  $\Lambda = 100$  μm film of Fig. 2(a),  $\xi_N(T) = 650$  Å, and thus  $K_N^{-1}$  is estimated to be 0.81 μm for  $T = 1.412$  K and  $T_{cN} = 1.394$  K. We note that the theory of de Gennes and Werthamer explicitly accounts for the possibility that the normal region is a superconductor above its transition temperature.

The critical current density  $J_c$  of dirty  $S$ - $N$ - $S$  junctions has been found to scale<sup>12,13</sup> as  $J_c = J_0(1 - T/T_{cs})^2 \times \exp(-K_N d_N)$ , where  $d_N$  is the length of the normal region ( $d_1$ ). For parameters of the  $\Lambda = 100$  μm film ( $d_N = 50$  μm), the exponential factor is of order  $10^{-27}$ . The constant  $J_0$  is typically less than  $10^7$  A/cm<sup>2</sup> in thin films, implying that  $J_c$  would be vanishingly small. This is clearly incompatible with our measured current density of at least 6 A/cm<sup>2</sup> close to  $T_c$ .

The de Gennes–Werthamer theory has been successful in describing experiments in the dirty limit to date. The theory assumes that the order parameter decays as a single exponential with characteristic length given by Eq. (2). Our system is always in the regime where the calculated  $K_N^{-1}$  is small compared with the length of the normal (etched) region. This is the requirement for the validity of the single-exponential description. However, the superconducting and normal regions of our system have nearly identical transition temperatures. This regime has not been explored by any previous experimenters. Provided the gap parameters are small (always satisfied near  $T_c$ ), there is no obvious reason to exclude the applicability of the theory in this regime.<sup>16</sup> We speculate that our system, with its similar  $T_c$ 's, may not be adequately described by a single-exponential decay of the order parameter.

To observe the limitations of and departure from existing theory, it would be useful to systematically increase  $\Delta T_c$  in a controlled fashion without significantly changing other transport properties. Unfortunately, a large shift of the  $T_c$  cannot be easily achieved using the present technique. Possible alternative approaches might include varying the thickness of the aluminum films, using magnetic/paramagnetic overlayers, and stronger etches to damage or remove the aluminum.

In conclusion, we have carried out a survey of the properties of a novel 2D analog of a modulated-transition-temperature superlattice. In the different

samples studied, homogeneous transitions are observed for samples having 1:1 modulation periods as large as 100 μm. The magnitude of the critical current, as well as the reasonable agreement with Eq. (1), strongly suggests that the order parameter decays over a length substantially longer than expected. We believe that a satisfactory explanation of this effect should also account for the observed trends in  $\Lambda$  and  $\Delta T_c$ .

We acknowledge helpful conversations with Professor R. Buhrman, Professor V. Ambegaokar, Professor R. Silsbee, Professor D. Rainer, and Professor D. Prober. This research was supported by AFOSR Grant No. 90-0111 and the Cornell Materials Science Center under Grant No. DMR-88-18558. All fabrication work was performed at the Cornell National Nanofabrication Facility under the support of NSF Grant No. ECS 8619094.

<sup>1</sup>J. Clarke, in *Nonequilibrium Superconductivity*, edited by D. N. Langenberg and A. I. Larkin (Elsevier, New York, 1986).

<sup>2</sup>K. K. Likharev, *Rev. Mod. Phys.* **51**, 101 (1979).

<sup>3</sup>B. Y. Jin and J. B. Ketterson, *Adv. Phys.* **38**, 189 (1989).

<sup>4</sup>G. Deutscher and P. G. de Gennes, in *Superconductivity*, edited by R. D. Parks (Marcel Dekker, New York, 1969).

<sup>5</sup>N. R. Werthamer, *Phys. Rev.* **132**, 2440 (1963).

<sup>6</sup>Here, normal refers to a superconductor at a temperature above its  $T_c$ .

<sup>7</sup>Y. K. Kwong *et al.*, *J. Vac. Sci. Technol. B* **7**, 2020 (1989).

<sup>8</sup>The Freon etch used in the process is not expected to react with the aluminum or the resist. The use of the word “etch” refers to the processing procedure and not the chemistry. We expect the process results in negligible removal of the aluminum.

<sup>9</sup>M. Tinkham, *Introduction to Superconductivity* (Krieger, Malabar, FL, 1980).

<sup>10</sup>Since the widths of the resistive transitions are similar for all films with homogeneous transitions, a different criterion for  $T_c$  would not affect the conclusions presented in this Letter.

<sup>11</sup>We have taken data on seven samples denoted  $A$  through  $G$ . A sample typically consists of two data sets with different configurations of  $d_1$  and  $d_2$ .

<sup>12</sup>J. Clarke, *Proc. Roy. Soc. London A* **308**, 447 (1969).

<sup>13</sup>For experiments performed in the clean limit, see, for example, J. G. Shepherd, *Proc. Roy. Soc. London A* **326**, 421 (1972). These and other experiments confirmed the clean-limit theory.

<sup>14</sup>For a discussion of the regime of validity for the de Gennes–Werthamer theory, see Clarke (Ref. 12), p. 462.

<sup>15</sup> $K_N$  is given by the roots of a transcendental equation. See, for example, Eq. (3) in P. G. de Gennes and J. P. Hurault, *Phys. Lett.* **17**, 181 (1965), and Eq. (18) of Ref. 4. Our numerical solution for  $K_N$  using this result agrees within 15% with the simpler Eq. (2) in the text for  $T/T_{cN}$  ranging from 1.004 to 2. Thus, Eq. (2) is adequate for estimating  $K_N^{-1}$ .

<sup>16</sup>It has been suggested to us that this system may be viewed as an array of thin-film  $S$ - $N$ - $S$  junctions in series, which may introduce different boundary conditions than those in the de Gennes–Werthamer theory.

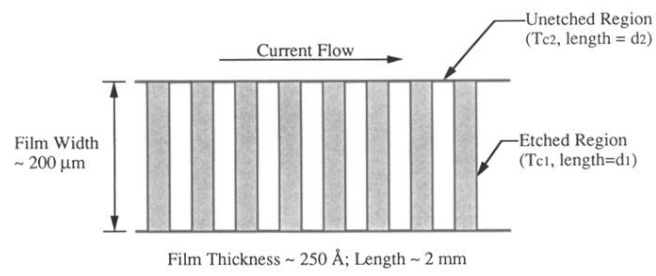


FIG. 1. Schematic of a modulated  $T_c$  structure, illustrating etched and unetched regions ( $d_1$ , etched length;  $d_2$ , unetched length).